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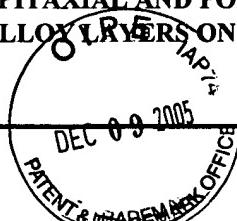
**AMENDMENT TRANSMITTAL LETTER (Large Entity)**

Applicant(s): Jack O. Chu et al.

Docket No.

YOR920010308US3 (16315B)

Application No. 10/775,514	Filing Date February 10, 2004	Examiner Johannes P. Mondt	Customer No. 23389	Group Art Unit 2826	Confirmation No. 1038
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Invention: **EPIAXIAL AND POLYCRYSTALLINE GROWTH OF Si<sub>1-x-y</sub>Ge<sub>x</sub>C<sub>y</sub> AND Si<sub>1-y</sub>C<sub>y</sub> ALLOY LAYERS ON Si BY UHV-CVD****COMMISSIONER FOR PATENTS:**

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

**CLAIMS AS AMENDED**

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	9 -	32 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	2 -	4 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- No additional fee is required for amendment.
- Please charge Deposit Account No. \_\_\_\_\_ in the amount of \_\_\_\_\_
- A check in the amount of \_\_\_\_\_ to cover the filing fee is enclosed.
- The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM
- Any additional filing fees required under 37 C.F.R. 1.16.
  - Any patent application processing fees under 37 CFR 1.17.
- Payment by credit card. Form PTO-2038.

**WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.**

*[Signature]*

Dated: December 5, 2005

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on December 5, 2005

(Date)

Signature of Person Mailing Correspondence

Leslie S. Szivos, Ph.D.

Typed or Printed Name of Person Mailing Correspondence

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Response Under 37 C.F.R. §1.116  
Examining Group 2826  
Expedited Procedure

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** Jack O. Chu, et al.      **Examiner:** Johannes P. MONDT  
**Serial No:** 10/775,514      **Art Unit:** 2826  
**Filed:** February 10, 2004      **Docket:** YOR920010308US3 (16315B)

**For:** EPITAXIAL AND POLYCRYSTALLINE  
GROWTH OF  $\text{Si}_{1-x-y}\text{Ge}_x\text{C}_y$  AND  $\text{Si}_{1-y}\text{C}_y$   
ALLOY LAYERS ON Si BY UHV-CVD

**Confirmation Number:** 1038

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 C.F.R. § 1.116**

Sir:

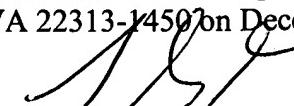
In response to the Final Office Action dated October 3, 2005, Applicants hereby submit the following amendments and remarks for entry of record in the above-identified patent application.

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**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

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Dated: December 5, 2005

  
Leslie S. Szivos, Ph.D.